



IFW

PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/625,243
Applicant: : PERRY, A.
Filed: : July 22, 2003
Title: : METHOD AND SYSTEM FOR ELECTRONIC
SPATIAL FILTERING OF SPECTRAL
REFLECTOMETER OPTICAL SIGNALS

TC/A.U. : 1765
Examiner : Vinh, L.

Atty. Docket No. : LAM2P426
Date : June 7, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 7, 2005.

Signed: 

Rick von Wohld

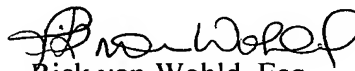
RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement dated May 10, 2005, Applicant hereby elects, without traverse, claims identified as Group II (claims 8-9, 19-23, drawn to a system for etching a wafer capable of determining endpoint of a plasma etching/a plasma processing system/apparatus, classified in class 156, subclass 345/25), to prosecute on the merits in the above-identified patent application.

Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number below.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP


Rick von Wohld, Esq.
Reg. No. 48,018

710 Lakeway Drive, Suite 200
Sunnyvale, CA 94085
Telephone (408) 749-6900
Customer Number 25920

Attorney Docket No. LAM2P426